Applicant:

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For:

Calibration Artifact and Method of Using the Same

ABSTRACT OF DISCLOSURE

A calibration artifact and a method of calibrating a machine vision measurement system. The calibration artifact includes a substrate and a number of concentric rings on one surface of the substrate. Each ring is of a different pre-defined size. The change in the size of any two adjacent rings is different than the change in size of any other two adjacent rings.

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